

WEST Search History

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DATE: Sunday, December 12, 2004

Hide?	Set Name	Query	Hit Count
		<i>DB=PGPB,USPT,USOC,EPAB,JPAB,DWPI,TDBD; PLUR=YES; OP=ADJ</i>	
<input type="checkbox"/>	L23	L21 and high temperature glass	0
<input type="checkbox"/>	L22	L21 and low temperature glass	0
<input type="checkbox"/>	L21	low temperature same bsg reflow	0
<input type="checkbox"/>	L20	low temperature near5 bsg reflow	0
<input type="checkbox"/>	L19	low temperature near5 bsg near4 reflow	0
<input type="checkbox"/>	L18	low temperature near5 bpsg near4 reflow	33
<input type="checkbox"/>	L17	low temperature near5 bpsg reflow	2
<input type="checkbox"/>	L16	low temperature bpsg reflow	0
<input type="checkbox"/>	L15	high temperature glasses are	0
<input type="checkbox"/>	L14	high temperature glasses include	2
<input type="checkbox"/>	L13	bpsg near5 high temperature glass	0
<input type="checkbox"/>	L12	l1 and outer layer of glass	0
<input type="checkbox"/>	L11	BPSG near5 low temperature glass	0
<input type="checkbox"/>	L10	l1 same (glaze)	4
<input type="checkbox"/>	L9	l1 same (glazed or glazing)	0
<input type="checkbox"/>	L8	l1 near5 (glazed or glazing)	0
<input type="checkbox"/>	L7	l4 and glazed	0
<input type="checkbox"/>	L6	L4 and hardened matrix	0
<input type="checkbox"/>	L5	l3 and (semiconductor or IC or printed circuit or wireboard)	2
<input type="checkbox"/>	L4	l1 near5 (sinter or sintered)	24
<input type="checkbox"/>	L3	gas filled same hollow microspheres	28
<input type="checkbox"/>	L2	ceramic L1 same substrate	3
<input type="checkbox"/>	L1	hollow microsphere	2418

END OF SEARCH HISTORY

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	2	("20010029974"):PN	US-PGPUB; USPAT; EPO; JPO; DERWENT ; IBM_TDB	OR	OFF	2004/12/12 21:25
L2	8	gas filled hollow microsphere	US-PGPUB; USPAT; EPO; JPO; DERWENT ; IBM_TDB	ADJ	ON	2004/12/12 21:26
L3	0	gas filled samehollow microsphere	US-PGPUB; USPAT; EPO; JPO; DERWENT ; IBM_TDB	ADJ	ON	2004/12/12 21:26
L4	28	gas filled same hollow microsphere	US-PGPUB; USPAT; EPO; JPO; DERWENT ; IBM_TDB	ADJ	ON	2004/12/12 21:26
L5	26	gas filled same hollow microsphere and @pd<"20030729"	US-PGPUB; USPAT; EPO; JPO; DERWENT ; IBM_TDB	ADJ	ON	2004/12/12 21:27
L6	0	gas filled same hollow microsphere and semiconductor @pd<"20030729"	US-PGPUB; USPAT; EPO; JPO; DERWENT ; IBM_TDB	ADJ	ON	2004/12/12 21:27